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Docket No. H1983

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **PATENT** application of:

Applicant: Tazrien Kamal et al.

Application No.: 10/729,732

Filing Date: December 5, 2003

For: HARD MASK SPACER FOR SUBLITHOGRAPHIC BITLINE

Art Unit: 2812

PRELIMINARY AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following remarks.